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Front Matter: Volume 7229

, "Front Matter: Volume 7229," Proc. SPIE 7229, Vertical-Cavity Surface-Emitting Lasers XIII, 722901 (19 February 2009); doi: 10.1117/12.823974

SPIE.

Event: SPIE OPTO: Integrated Optoelectronic Devices, 2009, San Jose, California, United States

PROCEEDINGS OF SPIE

Vertical-Cavity Surface-Emitting Lasers XIII

**Kent D. Choquette
Chun Lei**
Editors

**28–29 January 2009
San Jose, California, United States**

Sponsored and Published by
SPIE

Volume 7229

Proceedings of SPIE, 0277-786X, v. 7229

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Author(s), "Title of Paper," in *Vertical-Cavity Surface-Emitting Lasers XIII*, edited by Kent D. Choquette, Chun Lei, Proceedings of SPIE Vol. 7229 (SPIE, Bellingham, WA, 2009) Article CID Number.

ISSN 0277-786X

ISBN 9780819474759

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) • Fax +1 360 647 1445

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